In re U.S. Patent Application of)
SATO et al.) Art Unit 1765
Application Number: 10/648,399 Filed: August 27, 2003)) Examiner) Alanko, Anita Karen
For: Method For Converting and Purifying Materials For Modifying Surfaces of Semiconductor Nanoparticles)))
Attorney Docket No. HIRA.0122))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Office Action mailed on January 3, 2007, the period of response to which is set to expire on April 3, 2007. Please amend the above-referenced application as follows: